

**Scalings of High-Order Harmonics from Relativistic Electron Spikes****JAEA<sup>1</sup>, Osaka Univ.<sup>2</sup>, P. N. Lebedev Physical Institute<sup>3</sup>, Rutherford Appleton Laboratory<sup>4</sup>,****The Graduate School for the Creation of New Photonics Industries<sup>5</sup>****°A. S. Pirozhkov<sup>1</sup>, M. Kando<sup>1</sup>, T. Zh. Esirkepov<sup>1</sup>, T. A. Pikuz<sup>2</sup>, A. Ya. Faenov<sup>2</sup>, K. Ogura<sup>1</sup>, Y. Hayashi<sup>1</sup>,****H. Kotaki<sup>1</sup>, E. N. Ragozin<sup>3</sup>, D. Neely<sup>4</sup>, H. Kiriyama<sup>1</sup>, M. Tanoue<sup>1</sup>, Y. Nakai<sup>1</sup>, M. Okamoto<sup>1</sup>,****K. Torimoto<sup>1</sup>, S. Kondo<sup>1</sup>, S. Kanazawa<sup>1</sup>, J. K. Koga<sup>1</sup>, Y. Fukuda<sup>1</sup>, M. Nishikino<sup>1</sup>, T. Imazono<sup>1</sup>,****N. Hasegawa<sup>1</sup>, T. Kawachi<sup>1</sup>, H. Daido<sup>1</sup>, Y. Kato<sup>5</sup>, S. V. Bulanov<sup>1</sup>, and K. Kondo<sup>1</sup>****E-mail: pirozhkov.alexander@jaea.go.jp**

We experimentally study the new regime of relativistic high-order harmonic generation from gas jet targets driven by multi-terawatt relativistic-irradiance ( $>10^{18}$  W/cm<sup>2</sup>) femtosecond lasers [1, 2]. The XUV and soft x-ray harmonics are coherently emitted by extremely sharp, structurally stable, oscillating electron density spikes resulting from plasma flow catastrophes in relativistic plasma.

In experiments performed with the J-KAREN laser [3] we measured dependences of the harmonic yield on several parameters, including the gas jet density and laser pulse energy, and found a very steep dependence of the yield on the focal spot quality.

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2. A S. Pirozhkov, *et al.*, "High order harmonics from relativistic electron spikes," *New J. Phys.* **16** (9), 093003-30 (2014).
3. H. Kiriyama, *et al.*, "High temporal and spatial quality petawatt-class Ti:sapphire chirped-pulse amplification laser system," *Opt. Lett.* **35** (10), 1497-1499 (2010).